

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S)	Edouard D. de Fresart	GROUP ART UNIT:
APPLN. NO.:		EXAMINER:
FILED:	Concurrently Herewith	
TITLE:	SEMICONDUCTOR COMPONENT AND METHOD OF MANUFACTURING	

AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to examination of the above-referenced application please enter the following amendment: